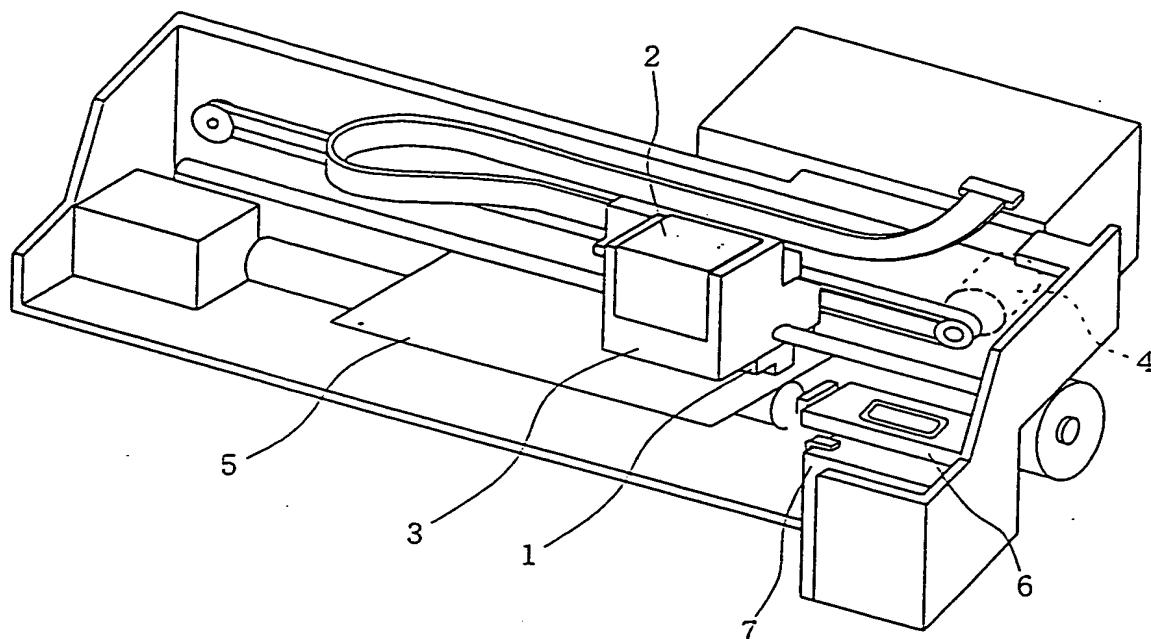


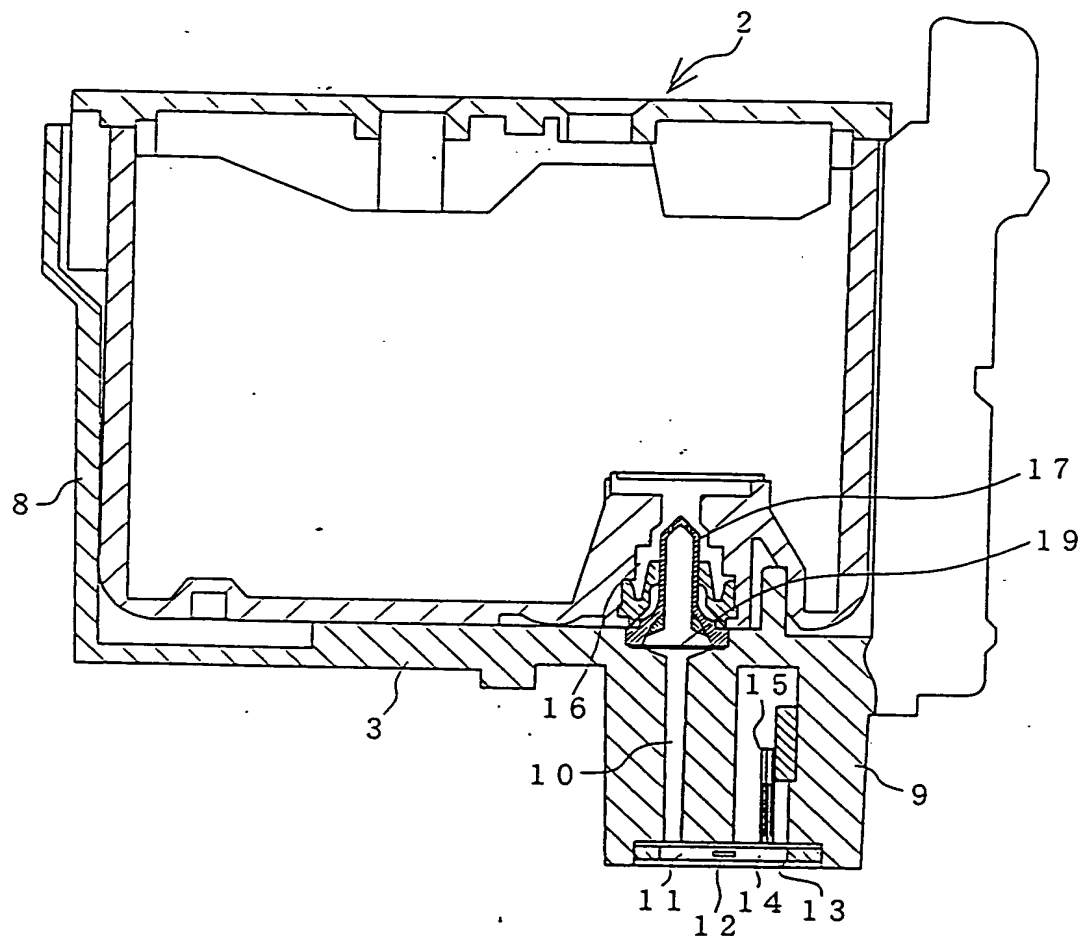
第1圖

FIG. 1



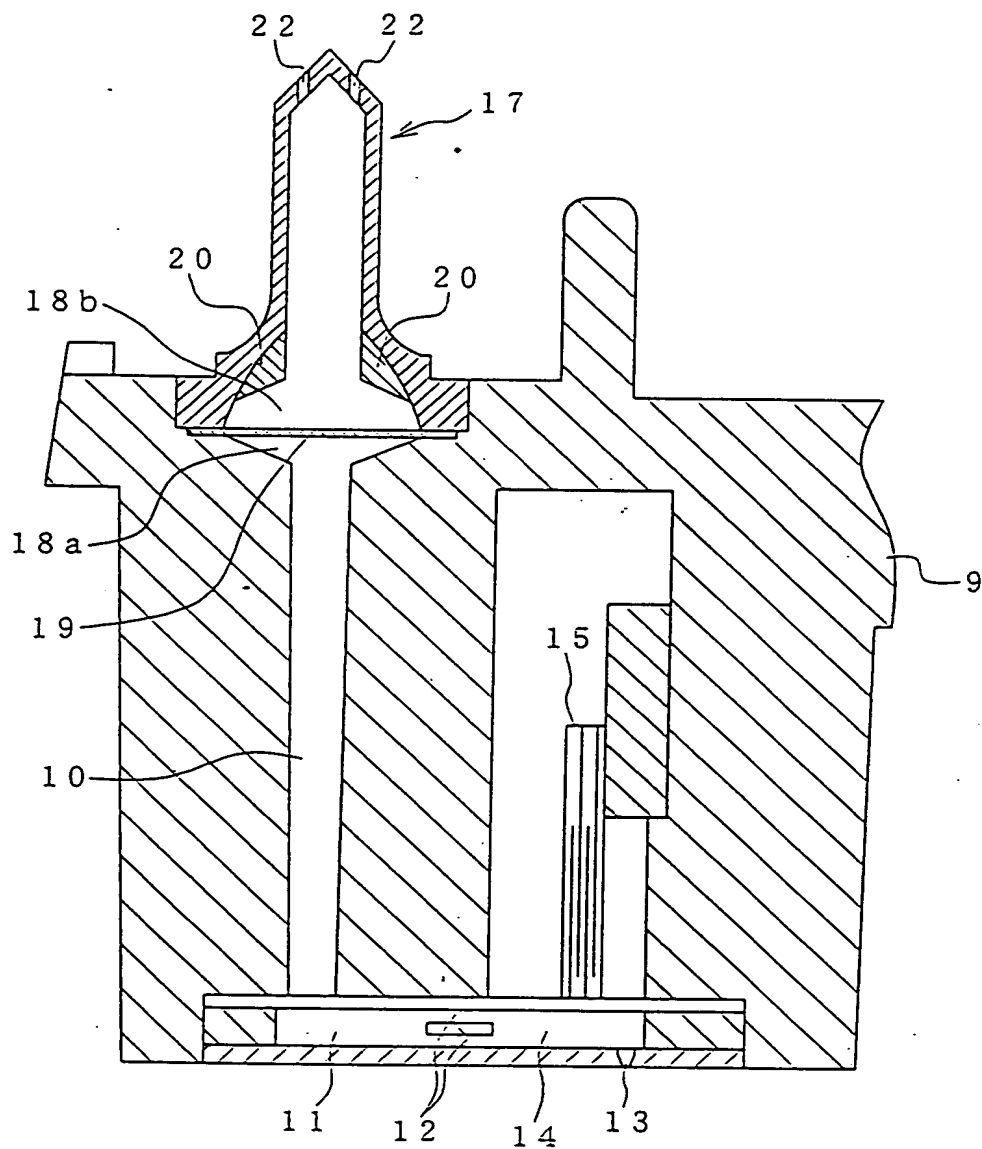
第2図

FIG. 2



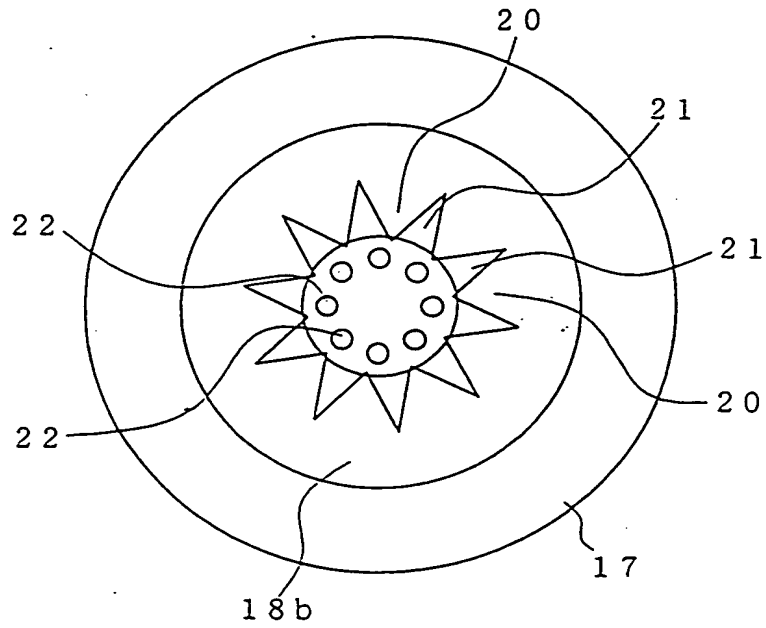
第3圖

FIG. 3

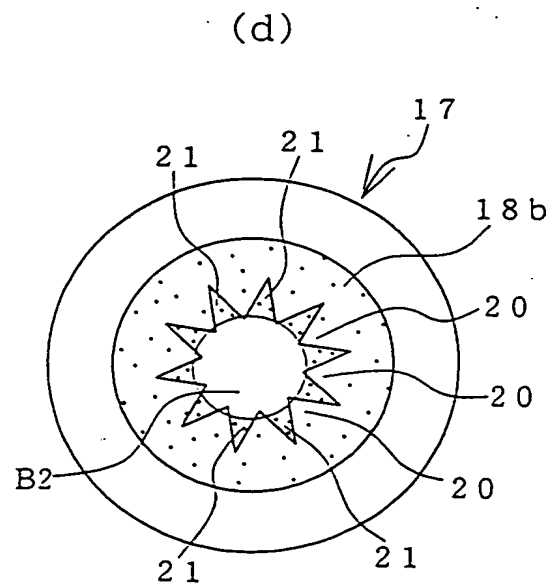
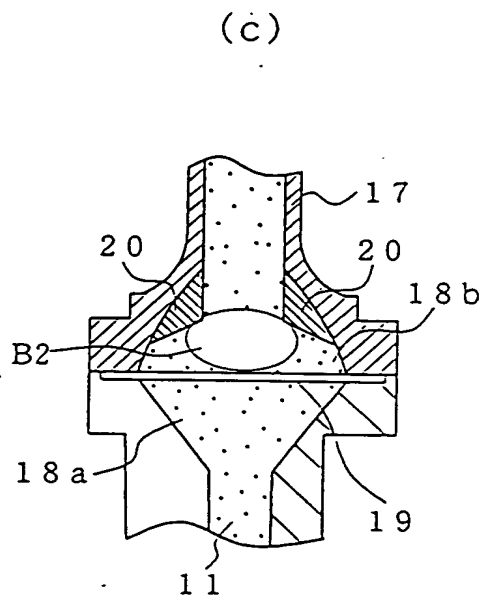
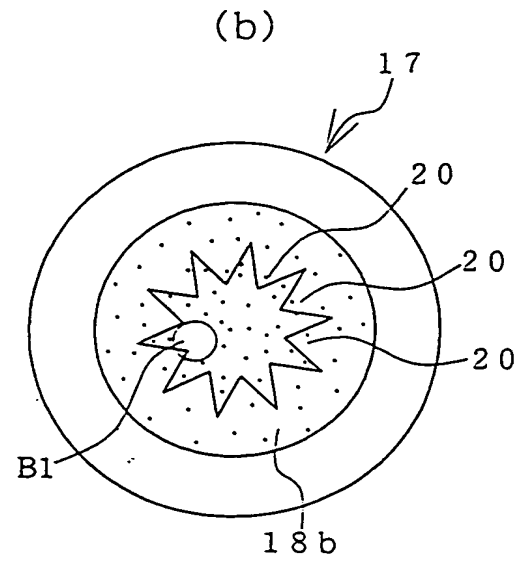
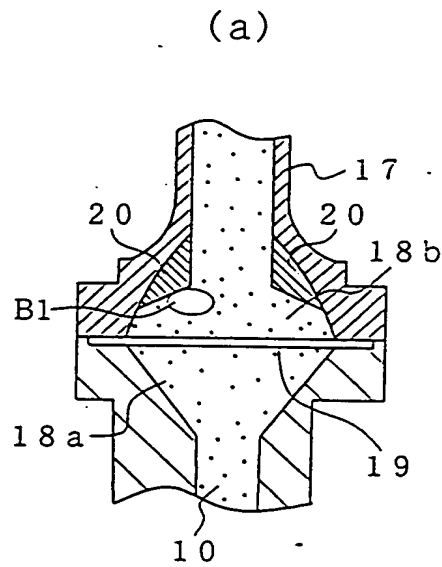


第4图

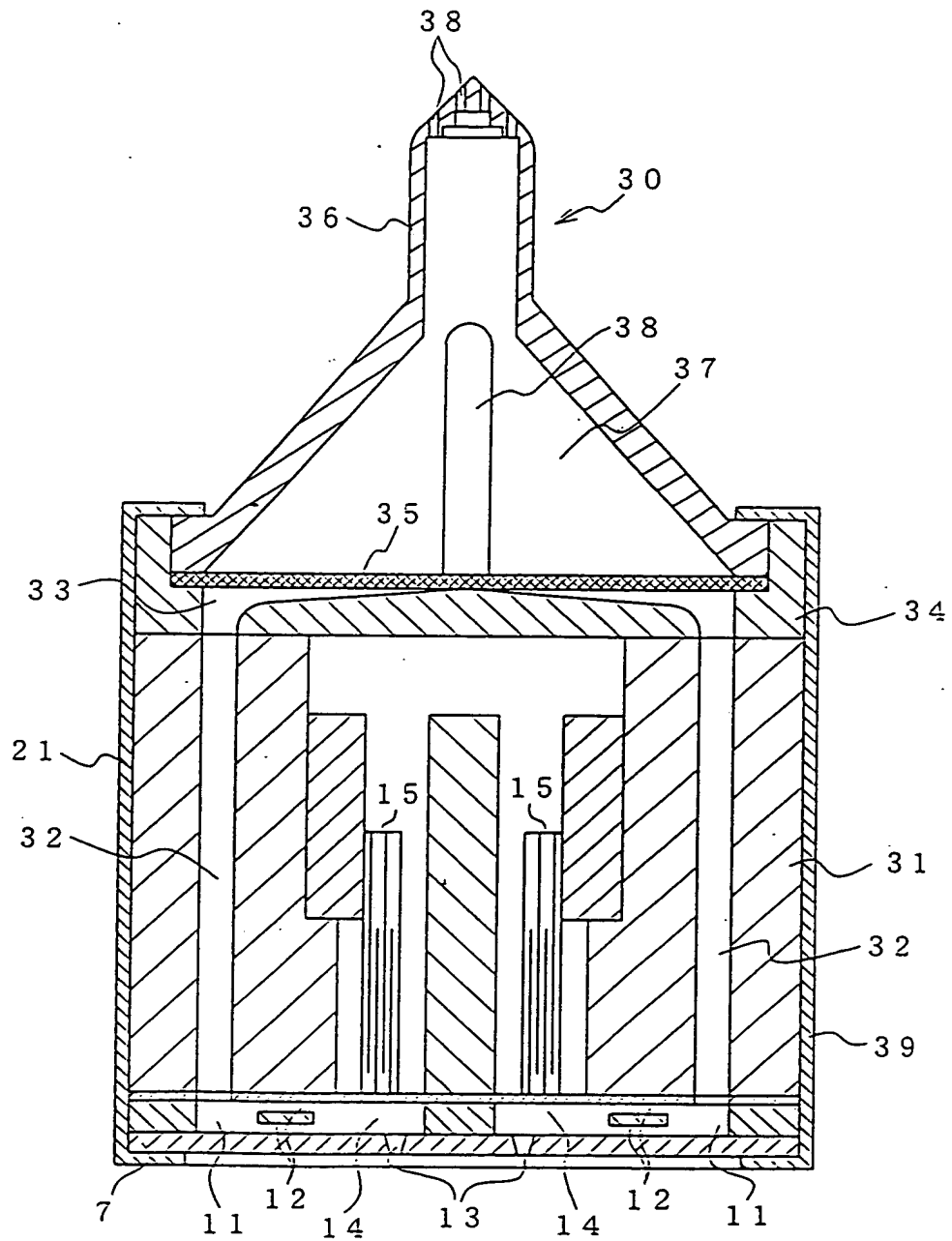
FIG. 4

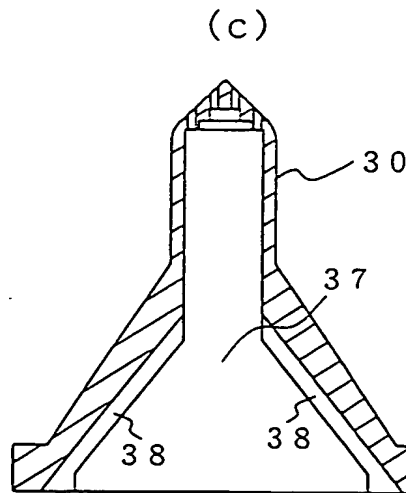
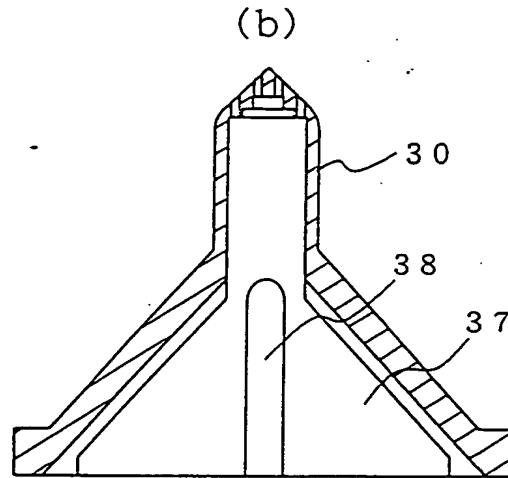
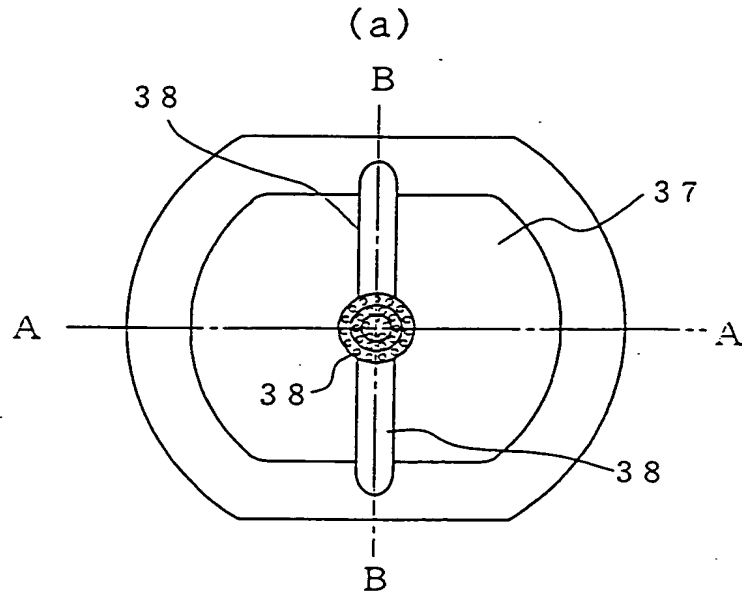


第5図
FIG. 5

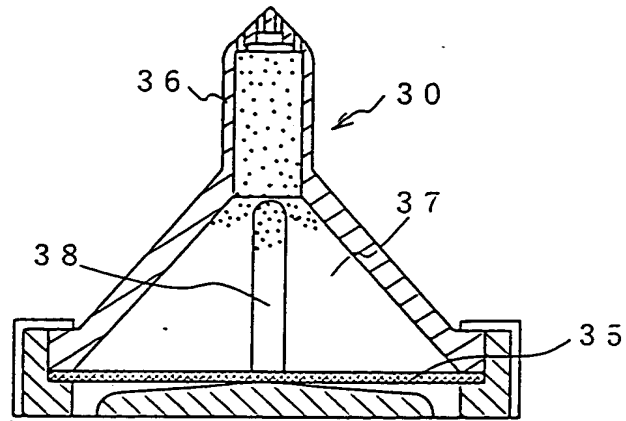


第6圖
FIG. 6

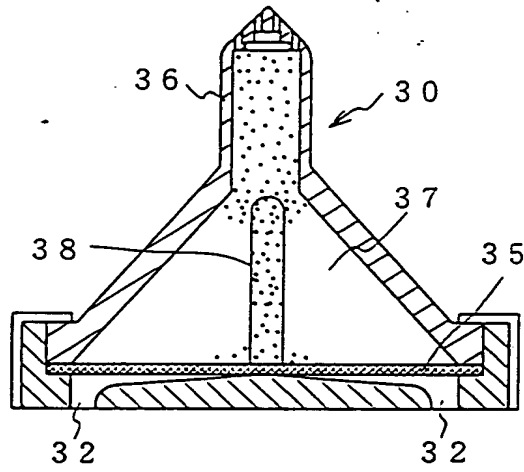




I



II



III

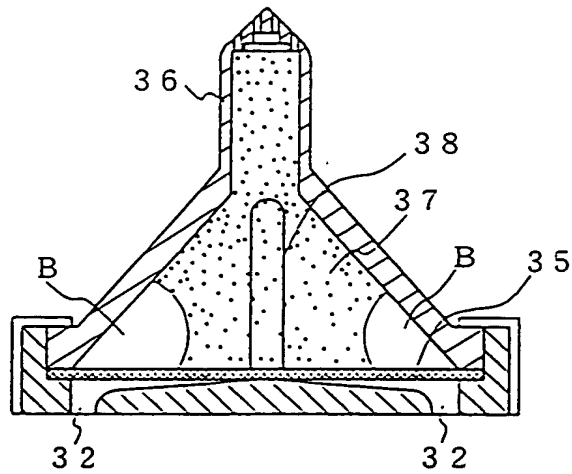


FIG. 9

第9図

09/242490

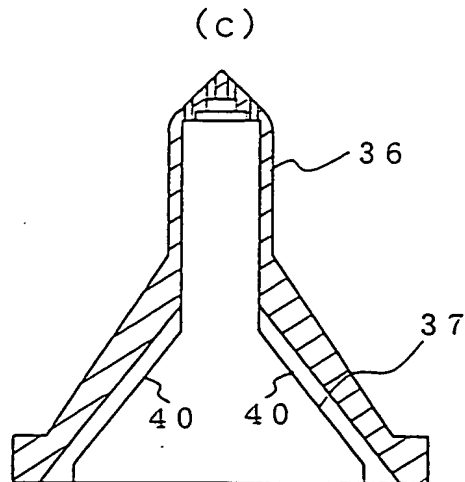
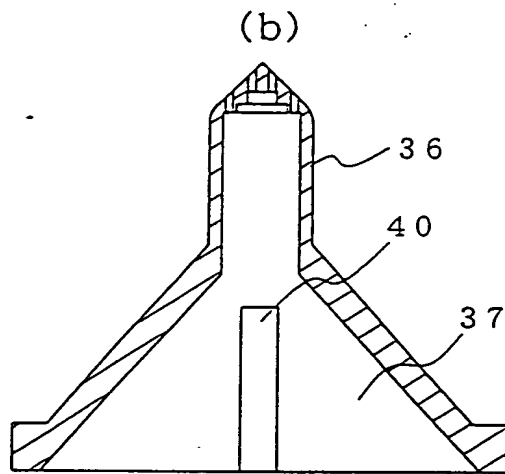
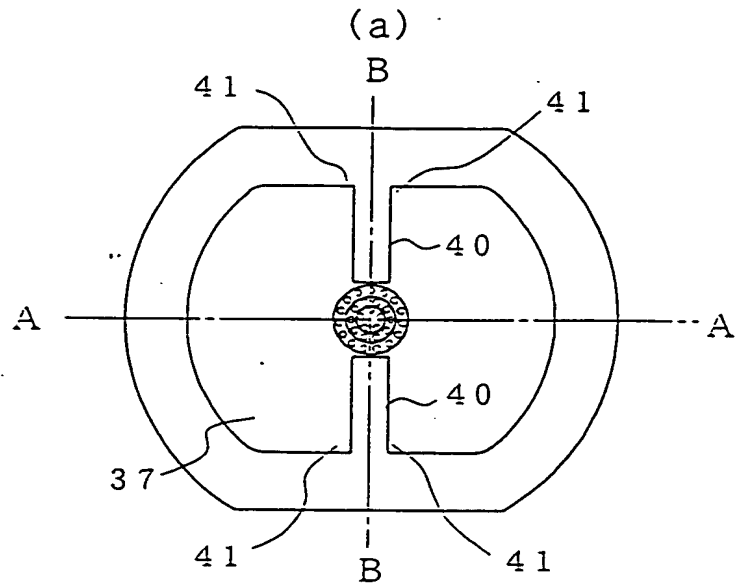


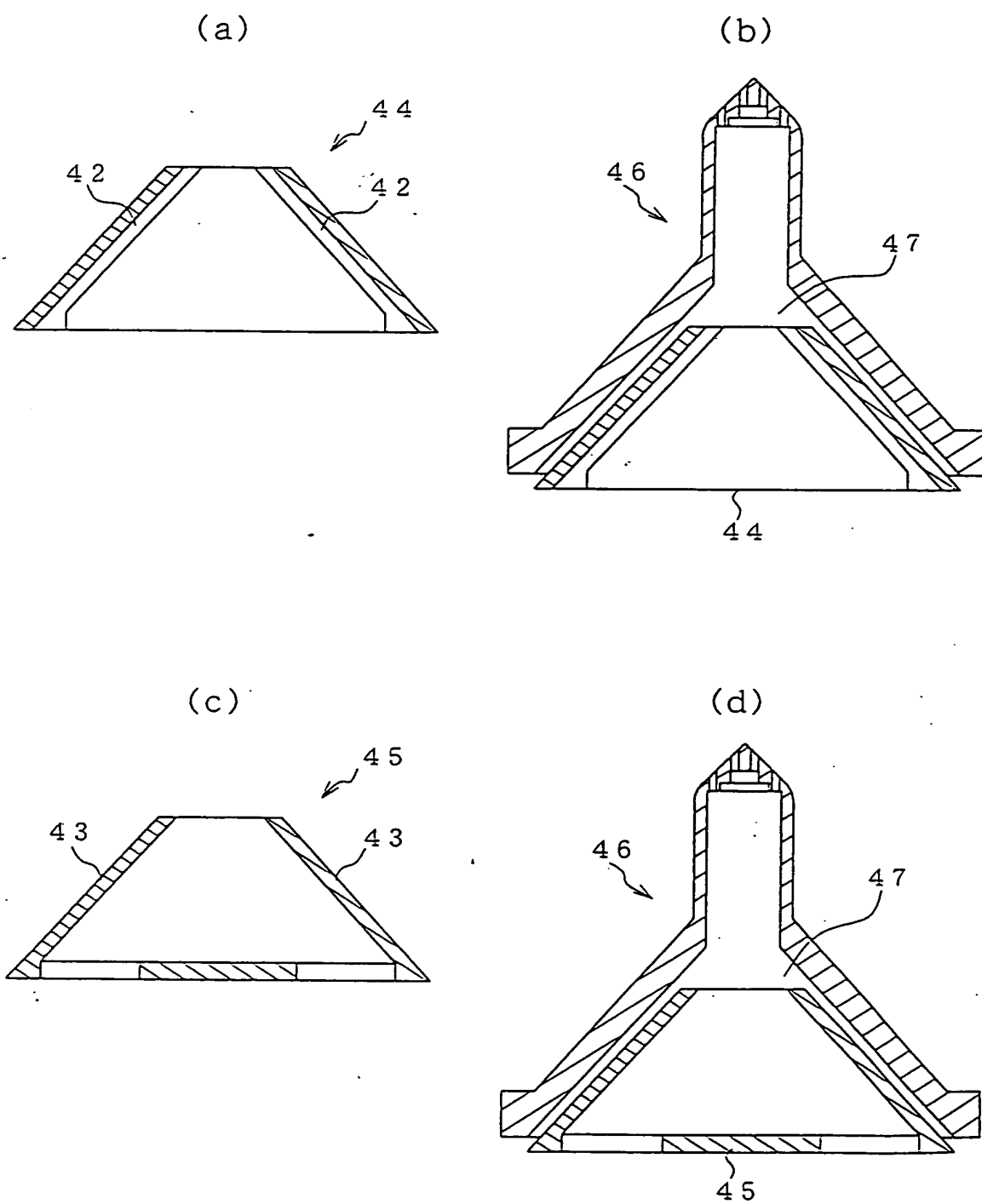
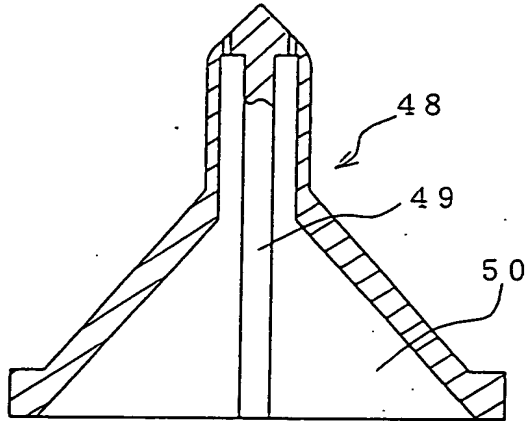
FIG. 10
第10图

Fig. 11

第11图

(a)



(b)

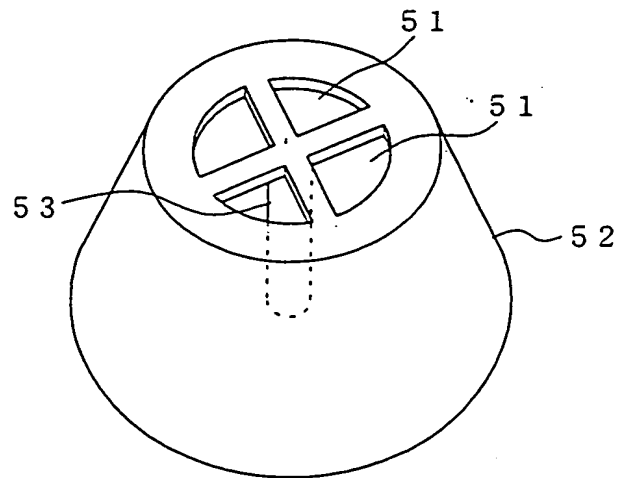
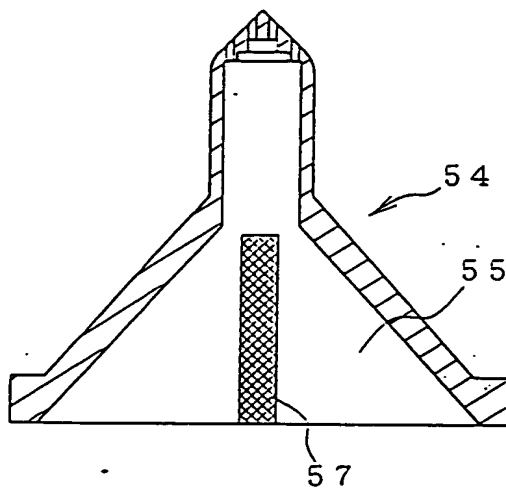


FIG. 12
第12圖

(a)



(b)

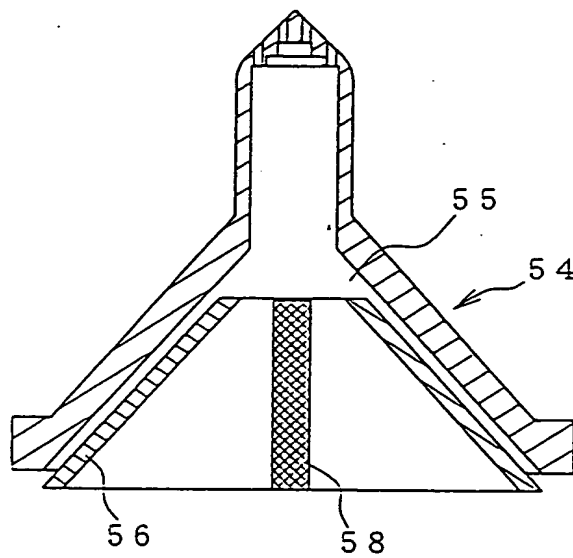


FIG. 13
第13図

